



NATIONAL
INSTITUTE OF
TECHNOLOGY
WARANGAL

JUNIOR RESEARCH FELLOW (JRF) RECRUITMENT



Anusandhan
National
Research
Foundation














PROJECT TITLE

Design and Development of Enhanced Flame Retardant Silicone Rubber Insulation Reinforced with Cost Effective Rare Earth Fillers for Outdoor High Voltage Applications.



SPONSORING AGENCY: Anusandhan National Research Foundation (ANRF), Gol

 POSITION TITLE Junior Research Fellow (JRF)	 DURATION 3 Years
 NUMBER OF POSITION(S) One	 ESSENTIAL QUALIFICATION • ME/M.Tech./Equivalent Degree in Electrical Engineering/Technology, or a related discipline in Electrical Engineering.
 DESIRED QUALIFICATIONS • Scholars who are selected through National Eligibility Tests – CSIR-UGC NET including lectureship (Assistant Professorship) or GATE are preferred Or • Candidate without CSIR-UGC NET including lectureship (Assistant Professorship) or GATE must appear for written test conducted by NIT Warangal	 AGE LIMIT • As per DST/ ANRF/NIT W Norms
	 AGE RELAXATION • As per DST/ ANRF/NIT W Norms
 EMOLUMENTS ₹ 37,000/- pm for first 2 years and ₹ 42,000/- pm for third year.	 HRA / ACCOMMODATION HRA as per institute rules
 JOB NATURE Execute the objectives of the Research project. Candidate will have opportunity to work with leading scientists working in the domain of HV Engineering in India and abroad.	 OTHER BENEFITS The selected candidates are eligible to register for PhD degree at NIT, Warangal as per institute rules. However, s/he needs to apply for PhD position when the advertisement is open.



HOW TO APPLY?

The proforma of application is attached with this advertisement. Complete and send to an email: pmishra@nitw.ac.in



SUBMISSION MODE

Soft copy



LAST DATE TO APPLY
30th June 2026



CONTACT EMAIL ID
pmishra@nitw.ac.in

WHOM TO CONTACT?

Dr. Palash Mishra (PI)
Assistant Professor
EED, NIT Warangal
Warangal - 506004, India
Ph. No. 9566160482
pmishra@nitw.ac.in

PLEASE NOTE:

- The position is purely temporary.
- Please enclose a brief resume/ curriculum vitae/ bio-data along with the application form.
- PI Team may put higher cut-off for shortlisting the candidates based on the applications received.
- List of eligible candidates will be announced on the institute website /and intimated via email or phone.
- Shortlisted candidate will have to attend written test and/or interview (Offline/Online).
- Mr. TA/PIA will be valid for appointment the Institute office.



APPLICATION FOR THE POSITION OF JUNIOR RESEARCH FELLOW (JRF)
Design and Development of Enhanced Flame Retardant Silicone Rubber Insulation Reinforced
with Cost Effective Rare Earth Fillers for Outdoor High Voltage Applications.

(Please enclose a copy of bio-data/ resume/ curriculum-vitae)

1. Name of the candidate
2. Father's name
3. Date of birth (DD/MM/YYYY)*
4. Sex Male/ Female
5. Marital status Single/ married
6. Category* OC/OBC/SC/ST/PwD/General
7. Educational qualifications*

Degree	Specialization/ subjects	Board/ University	Year of passing	Class	Percentage/ CGPA
SSC					
Intermediate					
B.E./B.Tech					
M.E./M.Tech					

8. GATE/ NET/ ICMR/ DBT-SRF score earned/ qualified (If Any)*

Score	Year appeared	Score	All India rank
GATE/ NET/ mention			

9. Research/Industrial/Teaching experience*

S.No.	Organisation/ industry served	Date/ Month of entry	Date/ Month of Leaving	Months/ Years of experience

10. Publications/ conference participations*

11. Mail id and mobile number :

12. Any other relevant information

Declaration

I hereby declare that all statements made in this application are true, complete and correct to the best of my knowledge and belief. In the event of the information being found false or incorrect or any ineligibility being detected before or after the selection, my candidature is liable to be cancelled. I confirm, that I am available for ONLINE interview, if necessary.

Date:

Signature of the candidate

* Submit soft copies of the supporting documents.